



PATENT
1691-0177PUS2

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Hiroyuki FUKUYAMA
Appl. No.: 10/809,398 Group: 1722
Filed: March 26, 2004 Examiner: Song
For: SINGLE CRYSTALLINE ALUMINUM
 NITRIDE FILM, METHOD OF FORMING THE
 SAME, BASE SUBSTRATE FOR GROUP III
 ELEMENT NITRIDE FILM, LIGHT EMITTING
 DEVICE AND SURFACE ACOUSTIC WAVE DEVICE

REQUEST FOR RECONSIDERATION

Commissioner of Patents
P.O. Box 1450
Alexandria, Virginia 22313

Sir:

The following Remarks are respectfully submitted in connection with the above-identified application in response to the Official Action of May 3, 2005, the period for response to which having been extended up to and including September 3, 2005.

No specification or claim amendments are made.